

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Izumi
Family Name::	FUSEGAWA
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Nobuaki
Family Name::	MITAMURA
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Takahiro
Family Name::	YANAGIMACHI
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number::	25944
----------------------------------	-------

Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None

Title:: METHOD FOR PRODUCING A SINGLE
 CRYSTAL AND SILICON SINGLE
 CRYSTAL WAFER
 Attorney Docket Number:: 126961
 Suggested Drawing Figure:: 1
 Total Drawing Sheets:: 5
 Small Entity:: No

Representative Information

Attorneys associated with Customer No. 25944.

Domestic Priority Information					
Application::	Continuity Type::	Parent Application::	Parent Filing Date::		
This Application is a	National Stage of	PCT/JP2004/011685	08/13/04		
Foreign Priority Information					
Country::	Application Number::	Filing Date::	Priority Claimed::		
Japan	2003-296837	08/20/03	Yes		
Assignee Information					
Assignee Name::	Shin-Etsu Handotai Co., Ltd.				
Street of mailing address::	4-2, Marunouchi 1-chome				
City of mailing address::	Chiyoda-ku				
State or Province of mailing address::	Tokyo				
Country of mailing address::	Japan				